

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor(s): Tue Nguyen et al.

Appn. No.: 09/898,439

Confirm. No.: 1885

Filed: July 5, 2001

Title: PLASMA SEMICONDUCTOR PROCESSING
SYSTEM AND METHOD

PATENT APPLICATION

Art Unit: 2892

Examiner: Quoc Dinh Hoang

Customer No. 23910

AMENDMENT UNDER 37 C.F.R. § 1.312

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is an Amendment Under 37 C.F.R. § 1.312.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Drawings begin on page 5 of this paper

Remarks begin on page 6 of this paper.

OK to enter.

QH